



00684.002535.3

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Yuichi YAMADA et al. ) : Examiner: Q. L. Tan  
Application No.: 10/024,139 ) : Group Art Unit: 2878  
Filed: December 21, 2001 ) : Allowed: May 20, 2003  
For: SCANNING EXPOSURE APPARATUS AND ) : Confirmation No.: 4039  
DEVICE MANUFACTURING METHOD : August 20, 2003  
(As Amended) )

**Mail Stop RCE**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Sir:

Prior to further examination on the merits, please amend the above-identified application  
as follows: